

Notic of References Cited	Application/Control No. 09/497,320	Applicant(s)/Patent Under Reexamination GHAEMMAGHAMI ET AL.	
	Examiner José R. Díaz	Art Unit 2815	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	NN9305233: "Self-Aligned Pocket Implantation Technology for Forming a Halo Type Device Using Selective Tungsten deposition." IBM Technical Disclosure Bulletin, May 1993, Vol. 36, No. 5, p. 233-236
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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